Search Notes			

Application/Control No. Applicant(s)/Patent under Reexamination		er
10/552,172	KURITA, HIROTAKA	
Examiner	Art Unit	
Jason Benton	3747	

SEARCHED					
Class	Subclass	Date	Examiner		
123	188.11,18 8.6,193.6, 193.5,193.	6/18/2007	JB		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		-		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST: aluminum, silicon, copper, cokwell hardness ,grin size, primary crystal, eutectic.	6/18/2007	JB
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